

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name,

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

SELF ALIGNED METHOD OF FORMING A SEMICONDUCTOR MEMORY ARRAY OF FLOATING GATE MEMORY CELLS WITH CONTROL GATE SPACERS, AND A MEMORY ARRAY MADE THEREBY

the specification of which (check one) X is attached hereto or was filed on as

Application No	and was amend	led on	(if applicable).
	e reviewed and understar amended by any amend	nd the contents of the above-iden ment referred to above.	tified specification,
I acknowledge the duty 1.56.	to disclose all information	on which is material to patentabil	lity as defined in 37 CFR §
application(s) for patent designated at least one of	t or inventor's certificate, country other than the Un for patent or inventor's c	U.S.C. § 119(a)-(d) or § 365(b) or § 365(a) of any PCT Internat nited States, listed below and havertificate having a filing date before	ional application which re also identified below
Prior Foreign Application	Priority Claimed Yes No		
Number	Country	Day/Month/Year Filed	
Number	Country	Day/Month/Year Filed	,
•	_	9(e) of any United States provision	onal application(s) below.
60/234,314	September 2	20, 2000	
Application Number	Filing Date		
60/233,988	September 2	20. 2000	
Application Number	Filing Date		
60/242,096	October 19,	2000	

I hereby claim the benefit under 35 U.S.C. § 120 of any United States application(s), or § 365(c) of any PCT International application designating the United States, listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of 35 U.S.C. § 112, I acknowledge the duty to disclose all information

which is material to patentability as defined in 37 CFR § 1.56 which became available between the filing date of the prior application and the national or PCT international filing date of this application:

Application Number	Filing Date	Status: Patented, Pending, Abandoned	
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Application Number	Filing Date	Status: Patented, Pending, Abandoned	
on information and belief are knowledge that willful false	e believed to be true statements and the l 1 and that such will!	of my own knowledge are true and that all statements made e; and further that these statements were made with the like so made are punishable by fine or imprisonment or ful false statements may jeopardize the validity of the	
Full name of sole or first inv	rentor <u>Ch</u>	ih Hsin Wang	
Inventor's signature			
		Date	
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Citizenship.			
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